

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:	)	
Yoshihisa NAGANO et al.	)	Group Art Unit: 2826
Serial No. 10/829,476	)	Examiner: Scott R. Wilson
Filed: 04/22/2004	)	Confirmation No. 5876
For: SEMICONDUCTOR DEVICE AND	)	Date: March 3, 2008
METHOD OF FABRICATING THE	)	
SAME	)	

CERTIFICATE OF MAILING OR TRANSMISSION  
[37 CFR 1.8(a)]

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Signature: \_\_\_\_\_

Name: \_\_\_\_\_

**AMENDMENT**

Mail Stop \_\_\_\_\_  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated November 2, 2002, please amend the above identified application as follows.